

CLEAN ROOM CONTACT NUMBERS

Name	Phone	Expertise
Larry Buck <i>laurence.buck@nist.gov</i>	301-975-2242	<ul style="list-style-type: none"> ➤ Facility and tool maintenance
Marc Cangemi <i>marc.cangemi@nist.gov</i>	301-975-5993	<ul style="list-style-type: none"> ➤ Photolithography ➤ Process support ➤ Photomask fabrication
Lei Chen <i>lei.chen@nist.gov</i>	301-975-2908	<ul style="list-style-type: none"> ➤ Nano-imprint lithography, ➤ Plasma etching, ➤ ALO, AFM
Russ Hajdaj <i>russ.hajdaj@nist.gov</i>	301-975-2699	<ul style="list-style-type: none"> ➤ Facility infrastructure, ➤ safety
Gerard Henein <i>gerard.henein@nist.gov</i>	301-975-5645	<ul style="list-style-type: none"> ➤ Metallization ➤ wire bonding
Mike Hernandez <i>michael.hernandez@nist.gov</i>	301-975-4590	<ul style="list-style-type: none"> ➤ SEM ➤ FIB
Rich Kasica <i>richard.kasica@nist.gov</i>	301-975-2693	<ul style="list-style-type: none"> ➤ E-beam lithography, ➤ SEM, FIB
Bill Young <i>bill.young@nist.gov</i>	301-975-4467	<ul style="list-style-type: none"> ➤ Equipment maintenance, modification and installation. ➤ Basic process support
Vincent Luciani <i>vincent.luciani@nist.gov</i>	301-975-2886	<ul style="list-style-type: none"> ➤ Facility Operations ➤ NanoFab Manager
Jeff Pasternak <i>jeff.pasternak@nist.gov</i>	301-975-4529	<ul style="list-style-type: none"> ➤ Nanofab user office